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APPLICATION NO.		FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
	10/001,423	12/03/2001	Tapesh Yadav	A21	4189	
	25235	7590 03/27/2003				
	HOGAN & HARTSON LLP			EXAMINER		
	1200 SEVENT			RAEVIS, R	OBERT R	
	DENVER, CO			ART UNIT	PAPER NUMBER	
	•			2856		
				DATE MAILED: 03/27/2003		

Please find below and/or attached an Office communication concerning this application or proceeding.

•		Applicati n No	· •	Applicant(s)					
		10/001,423	,	YADAV ET AL.					
	Offic Action Summary	Examiner		Art Unit					
		Robert R. Rae		2856					
	The MAILING DATE of this communication app	pears on the cove	er sheet with the c	orrespond nce ad	ldress				
Period fo	ORTENED STATUTORY PERIOD FOR REPL	VIS SET TO EX	PIRE 3 MONTH(S) FROM					
THE - Exte after - If the - If NO - Failu - Any	MAILING DATE OF THIS COMMUNICATION. Insions of time may be available under the provisions of 37 CFR 1.1 SIX (6) MONTHS from the mailing date of this communication. Depend for reply specified above is less than thirty (30) days, a replector property of the provision of the pr	136(a). In no event, how by within the statutory m will apply and will expire a. cause the application	vever, may a reply be tim inimum of thirty (30) days e SIX (6) MONTHS from to become ABANDONEI	ely filed s will be considered timel the mailing date of this c O (35 U.S.C. § 133).	ly. ommunication.				
1)⊠	Responsive to communication(s) filed on 10	<u> March 2003</u> .							
2a)□	This action is FINAL . 2b)⊠ Th	nis action is non-	final.						
3) Since this application is in condition for allowance except for formal matters, prosecution as to the ments is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213. Disposition of Claims									
•		annlication							
4)[4)⊠ Claim(s) 1-12 and 21-29 is/are pending in the application. 4a) Of the above claim(s) 3-6,8-12 and 22-29 is/are withdrawn from consideration. 								
5\	Claim(s) is/are allowed.								
·	Claim(s) 1,2,7 and 21 is/are rejected.								
•	7) Claim(s) 1.2.7 and 27 is/are rejected.								
	Claim(s) are subject to restriction and/o	or election requir	ement.						
•	ion Papers								
9) 🗌	The specification is objected to by the Examine	er.							
10)	The drawing(s) filed on is/are: a) acce	pted or b)⊡ objec	cted to by the Exa	miner.					
	Applicant may not request that any objection to the	ne drawing(s) be h	eld in abeyance. So	ee 37 CFR 1.85(a).					
11)	The proposed drawing correction filed on	_ is: a)□ appro\	/ed b)□ disappro	ved by the Examin	er.				
	If approved, corrected drawings are required in re	ply to this Office a	ction.						
12)	The oath or declaration is objected to by the Ex	xaminer.							
Priority (under 35 U.S.C. §§ 119 and 120								
13)	Acknowledgment is made of a claim for foreig	n priority under 3	35 U.S.C. § 119(a)-(d) or (f).					
a)	☐ All b)☐ Some * c)☐ None of:	•							
	1. Certified copies of the priority document	ts have been rec	eived.						
	2. Certified copies of the priority document	ts have been red	eived in Applicati	on No					
* 9	 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. 								
	14) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).								
á	a) The translation of the foreign language provisional application has been received. 5) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121.								
اسروا Attachmer		,,							
1) 🔯 Notic 2) 🔲 Notic	ce of References Cited (PTO-892) ce of Draftsperson's Patent Drawing Review (PTO-948) mation Disclosure Statement(s) (PTO-1449) Paper No(s) _	5)	Interview Summary Notice of Informal f Other:						

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DETAILED ACTION

Election of claim 21 (nanomaterial including zinc that is sensitive to hydrogen) is acknowledged.

The drawings are objected to because Figure 2C is not labeled such in the drawings. A proposed drawing correction or corrected drawings are required in reply to the Office action to avoid abandonment of the application. The objection to the drawings will not be held in abeyance.

The disclosure is objected to because of the following informalities: the Brief Description of the Drawings does not refer to Figures 2a, 2b, 2c, 4a, 4b, 5a, 5b.

Appropriate correction is required.

Claims 1, 2, 7 and 21 are rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention.

As to claim 1, what does "quantum-confined" physically mean in this apparatus claim? Also, what does the term –nano—add to the term –material—in "nanomaterial"? What is a "nanomaterial? Is the term "nano" related to a weight, mass or dimension of some type?

Claims 1, 2, 7 and 21 are rejected under 35 U.S.C. 112, first paragraph, as containing subject matter which was not described in the specification in such a way as to enable one skilled in the art to which it pertains, or with which it is most nearly connected, to make and/or use the invention. As to claim 1, how is a "nanomaterial" made such that it is "quantum-confined"?

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The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 1 and 2 are rejected under 35 U.S.C. 102(b0) as anticipated by or, in the alternative, under 35 U.S.C. 103(a) as obvious over Shigekuni (JP 08261979).

Shigekuni teaches a device comprising, laminated structure including 10nm layers of metal layer and 10nm layers of Silicon dioxide, the device applied as gas detector, thus sensitive to gas.

As to claim 1, the term "nm" seems to be suggestive of nanometer, thus making the material "nanomaterial". Also, gases are reactive, and thus are chemicals to that extent.

Claim 1 is rejected under 35 U.S.C. 103(a) as being unpatentable over Chen et al in view of Barbee, Jr. et al.

Chen et al teach a sensor, including: layers of dielectric and electrodes, but the layers are not "nanomaterial".

As to claim 1, Chen's "Depending on the deposition method" (col. 4, line 52) reference suggests any deposition technique, suggestive of Barbee's (col. 7, lines 50-

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56; col. 8, lines 20-30) sputtering technique that uses nanostructure materials. The term "nanostructure" material suggests nanomaterial as claimed.

Claims 1, 2 and 7 are rejected under 35 U.S.C. 102(b) as anticipated by or, in the alternative, under 35 U.S.C. 103(a) as obvious over any one of Hoenig et al, Cheng et al, Sibbald et al or Volt.

Hoenig et al teach a hydrogen (col. 1, line 23) sensor that employs "electrode" (col. 1, line 34) and hydrogen sensitive material (col. 7, lines 20-25) with nanometer size ("nm" on col. 7, line 15) dielectric layer.

As to claims 1, 2 and 7, the layers may be deemed to be laminate, and the nanomaterial is confined with respect to the sensor structure.

Chen et al teach a "hydrogen" sensor employing nanometer ("nanometers" on col. 3, line 33) material.

As to claims 1, 2 and 7, the layers may be deemed to be laminate, and the nanometer material is confined with respect to the sensor structure. Also, leads 42 suggest electrodes.

Sibald et al teach a "hydrogen" sensitive sensor employing "electrode" (col. 2, line 60) and nanomaterial ("nm" on col. 3, line 6).

As to claims 1, 2 and 7, the layers may be deemed to be laminate, and the nanomaterial is confined with respect to the sensor.

Claim1, 2 and 21 are rejected under 35 U.S.C. 103(a) as being unpatentable over Neuburger.

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Neuburger teaches a device for sensing gas, comprising crystal having a "50-200 nm thick coating of zinc" (col. 5, line 15).

Nueburger's written specification does not use the phrase "quantum-confined" or electrode.

As to claims 1, 2 and 21, the zinc is confined to a region on the crystal, and to that extent is "confined" as claimed. Also, the circuitry connections in Neuburger's detectors 122 pass electrical current, and to that extent are electrodes as claimed.

The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Voit teaches hydrogen sensor that employs 200 nm dimensions with respect to the layers.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Robert R. Raevis whose telephone number is 703-305-4919. The examiner can normally be reached on Monday to Friday from 6:30am to 4:00pm. The fax phone number for the organization where this application or proceeding is assigned is 703-308-7722.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703-305-4900.

ROVUS RAEVIS AU2856